



MAIL STOP AF  
PATENT  
8038-1047

AF (JRW)  
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IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Naruhiko NAKANISHI

Conf. 6943

Application No. 10/691,584

Group 2814

Filed October 24, 2003

Examiner Nathan W. Ha

METHOD FOR FORMING A CAPACITOR HAVING  
A HIGH-DIELECTRIC-CONSTANT INSULATION FILM

AMENDMENT AFTER FINAL REJECTION

Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

July 11, 2005

Sir:

In response to the Office Action mailed March 10, 2005,  
please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing  
of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.

Don't enter  
7/19/05